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2815

PATENT
98095DIV4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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MAR 03 2004

Art Unit: 2815

Examiner: Richards

In re application of:

Gonzalez et al.

SEMICONDUCTOR RAISED

SOURCE-DRAIN STRUCTURE

Serial No.: 10/008,653

Filed: November 9, 2001

RESPONSE TO OFFICE ACTION

February 26, 2004

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

Applicants respectfully request entry of the following amendments and remarks contained herein in response to the Office Action mailed December 3, 2003. Applicants respectfully submit that the amendments and remarks contained herein place the instant application in condition for allowance, wherein:

Amendments to the claims begin on page 2; and

Remarks begin on page 7.

Express Mail Number EU990159821US

Date of Deposit February 26, 2004

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Mail Stop Non-Fee Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.